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** CONTINUING DATA **********************************									
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged Exa		ter SC itials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTA CLAII 69	MS	INDEPENDENT CLAIMS 4		
ADDRESS 30593 HARNESS, DICKEY & PIERCE, P.L.C. P.O. BOX 8910 RESTON , VA 20195									
TITLE Method of fabricating a semiconductor device having a silicon oxide layer, a method of fabricating a semiconductor device having dual spacers, a method of forming a silicon oxide layer on a substrate, and a method of forming dual spacers on a conductive material layer									
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